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**TRANSMITTAL
FORM***(to be used for all correspondence after initial filing)*

Total Number of Pages in This Submission

Application Number 09/234,233

Filing Date January 20, 1999

First Named Inventor Weimin Li

Art Unit 2818

Examiner Name D. Vu

Attorney Docket Number MI22-1035

ENCLOSURES (Check all that apply)

- | | | |
|--|---|---|
| <input type="checkbox"/> Fee Transmittal Form | <input type="checkbox"/> Drawing(s) | <input type="checkbox"/> After Allowance Communication to a Technology Center (TC) |
| <input type="checkbox"/> Fee Attached | <input type="checkbox"/> Licensing-related Papers | <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences |
| <input type="checkbox"/> Amendment/Reply | <input type="checkbox"/> Petition | <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) |
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| <input type="checkbox"/> Affidavits/declaration(s) | <input type="checkbox"/> Power of Attorney, Revocation | <input type="checkbox"/> Status Letter |
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| <input type="checkbox"/> Express Abandonment Request | <input type="checkbox"/> Terminal Disclaimer | PTO-1449 |
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Remarks

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The Commissioner is hereby authorized to charge any additional fees required under 37 C.F.R. Section 1.16 and Section 1.17 and credit any overpayments to account no. 23-0925.

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENTFirm or Individual James E. Lake
Reg. No. 44,854, Wells St. John P.S.

Signature

Date

25 Jun 2004**CERTIFICATE OF TRANSMISSION/MAILING**I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date:

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EV372451881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/234,233
Filing Date January 20, 1999
Inventor Weimin Li, et al
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner D. Vu
Attorney's Docket No. MI22-1035
Title: Semiconductor Processing Methods

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

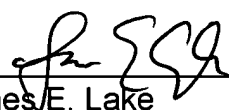
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of a Request for Continued Examination (RCE) Application and prior to the receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 25 Jun 2004

By: 
James E. Lake
Reg. No. 44,854

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200 Form PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MI22-1035SERIAL NO.
09/234,233LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Weimin LiFILING DATE
January 20, 1999GROUP
2818

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,971,655	11-90	Stefano et al.			
	AB	6,498,084B2	12-02	Bergemont			
	AC	5,036,383	07-91	Mori			
	AD	6,638,875	10/03	Han et al			
	AE	6,720,247	04/04	Kirkpatrick et al			
	AF	6,723,631	04/04	Noguchi et al			
	AG	6,627,535	09/03	MacNeil et al			
	AH	5,593,741	01/97	Ikeda			
	AI	2003/0077916	04/03	Xu et al			
	AJ	2003/0207594	11/03	Catabay et al			
	AK	2004/0071878	04/04	Schuhmacher et al			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	08-045926A	2/96	Japan				
	AM	JP8051058	02/96	Japan				
	AN	JP63316476	12/88	Japan				
	AO	JP8078322	03/96	Japan				

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AP		Wolf, S., Silicon Process., Vol. 3 pg. 635
	AQ		
	AR		

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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